

Photocathode Studies for BNL ERL

Triveni Rao

Outline

- Introduction
- Photocathode tests in guns
- Photocathode characterization and Optimization

Two Parallel Paths

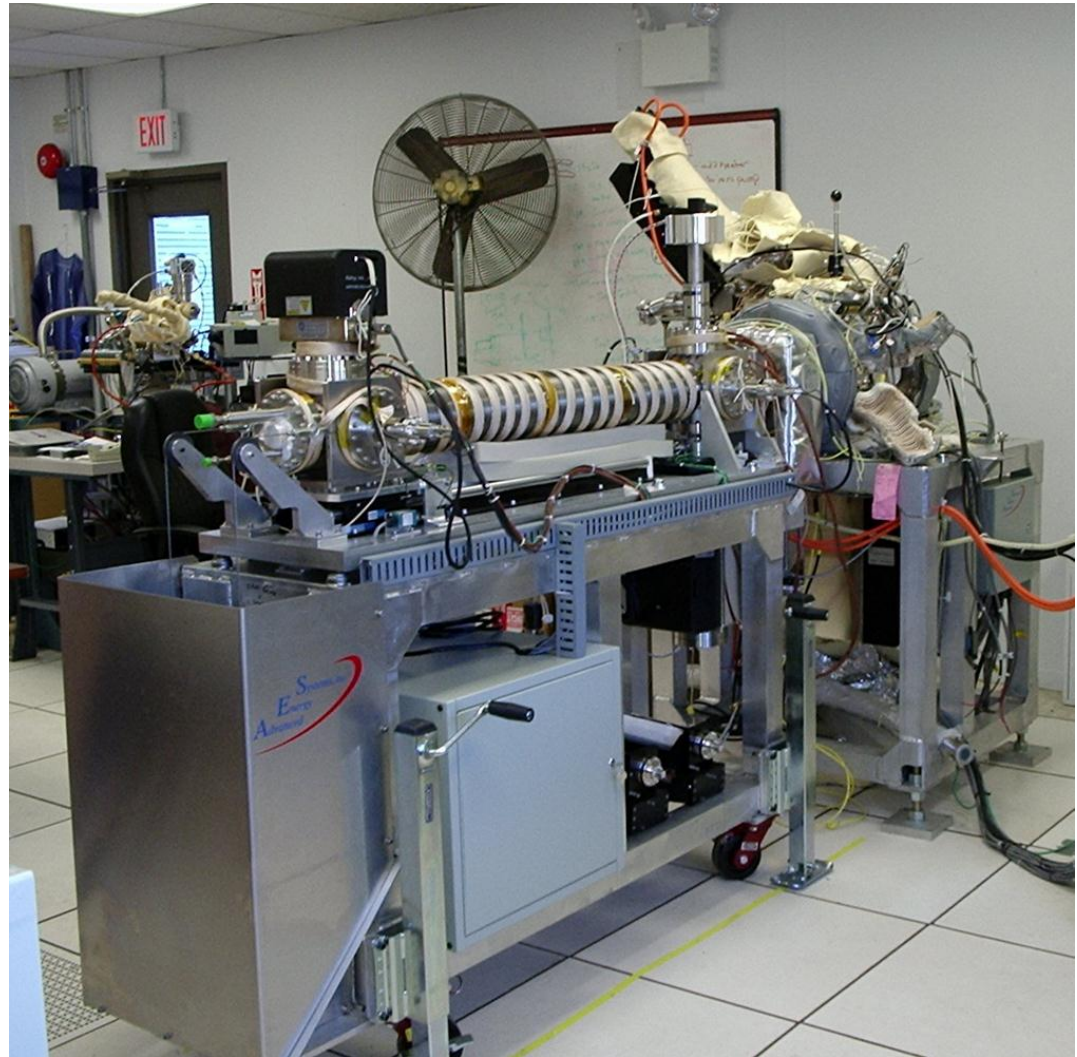
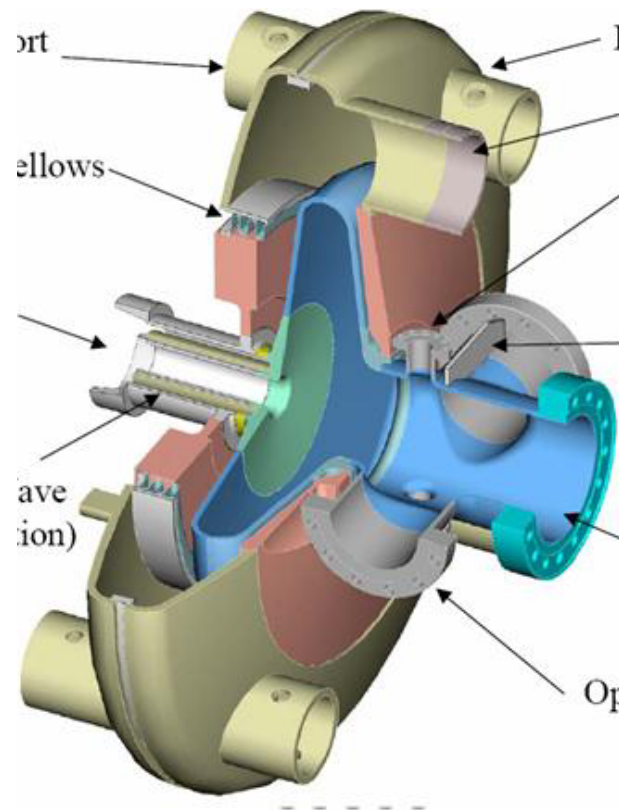
Testing in the gun

- **NCRF gun** Collaboration with LBNL
- **SCRF Gun**
 - 704 MHz
 - 112 MHz
- **DC Gun** Collaboration with JLab

Growth, Characterization and Optimization-Pre and Post analysis

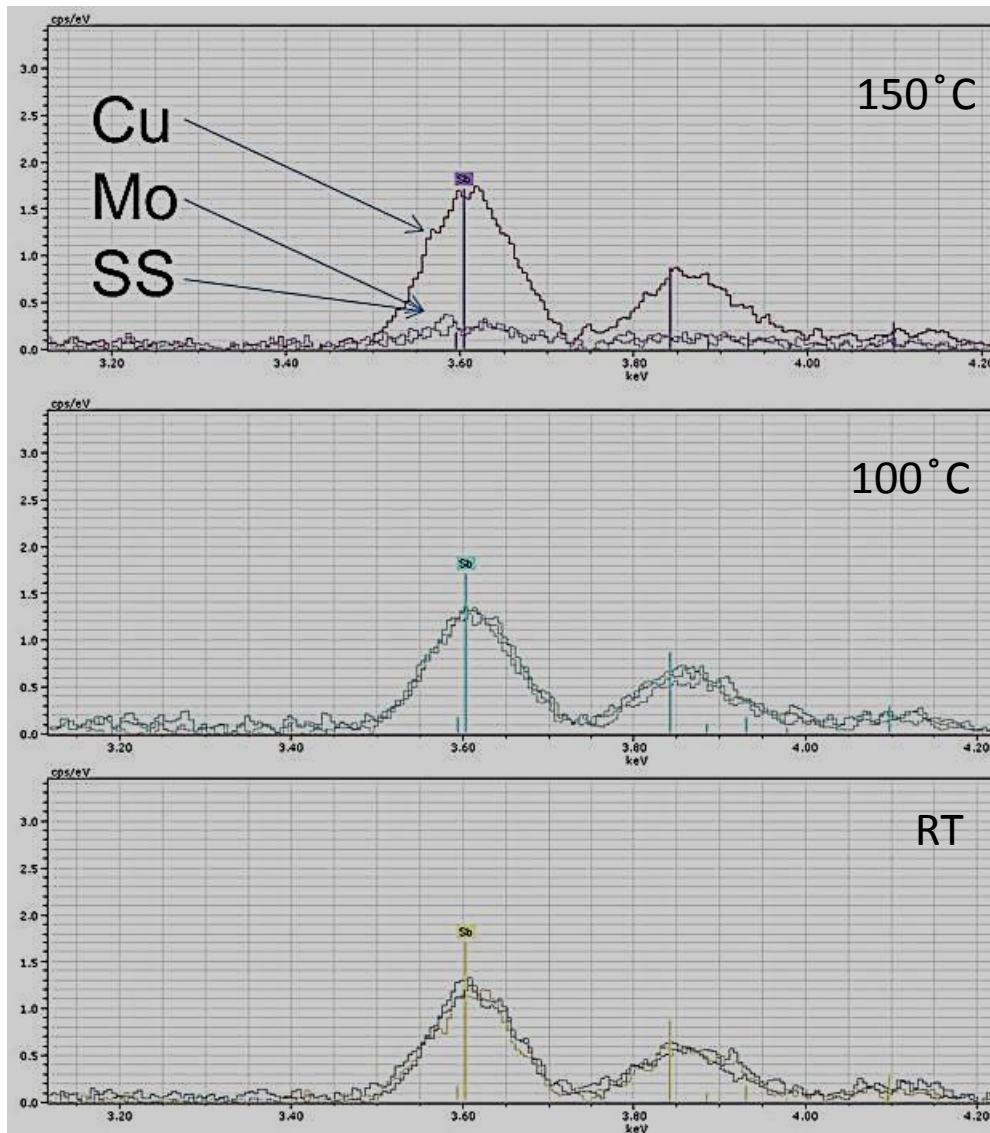
- **XRR, SEM & AFM-** Thickness and roughness
- **XRD-** Texture
- **XPS & EDS-** Material composition
- **ARPES-** electron energy, velocity distribution

704 MHz gun



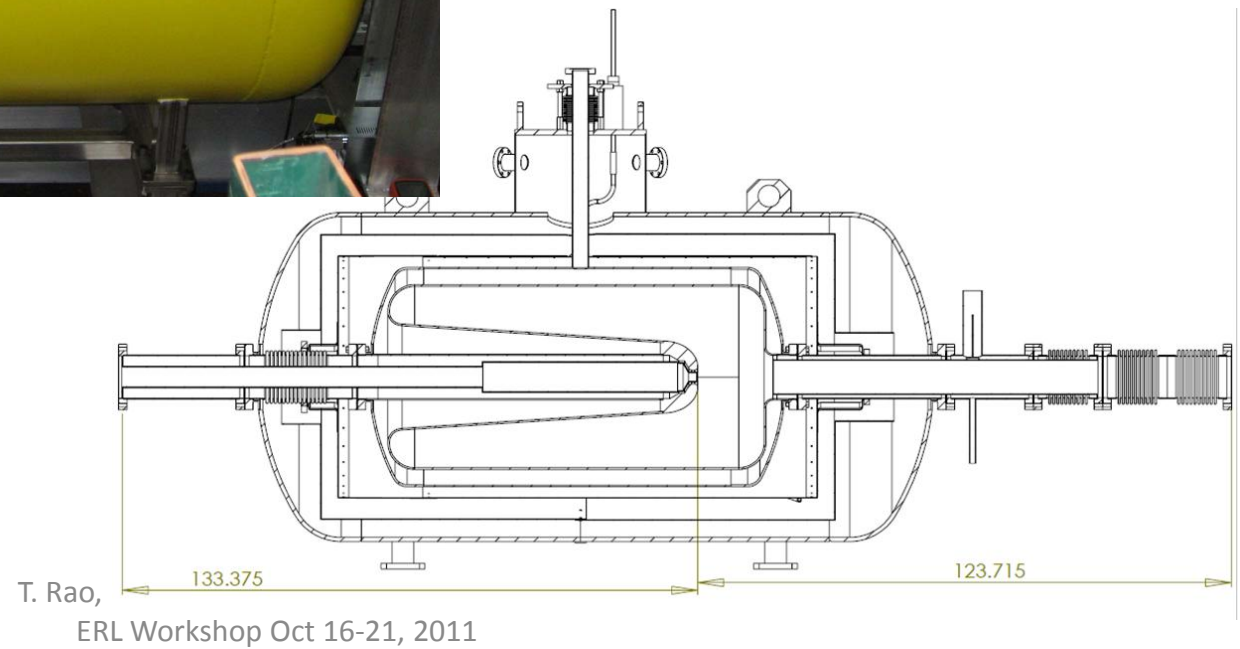
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ERL Workshop Oct 16-21, 2011

EDS of Sb on Cu, Mo, & SS

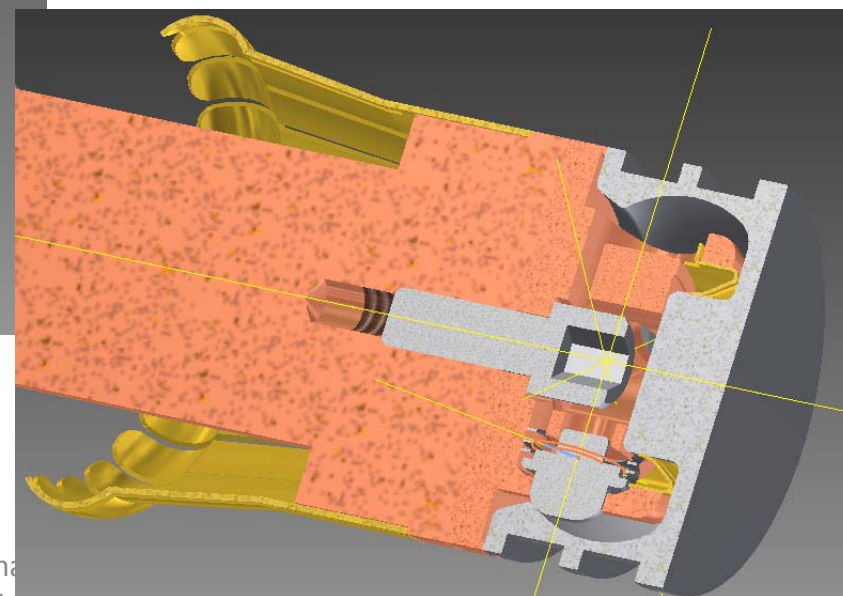
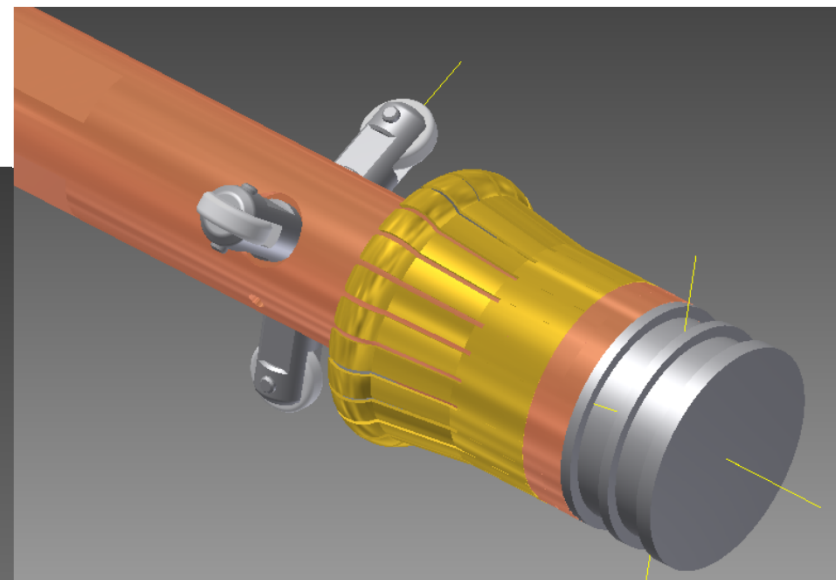
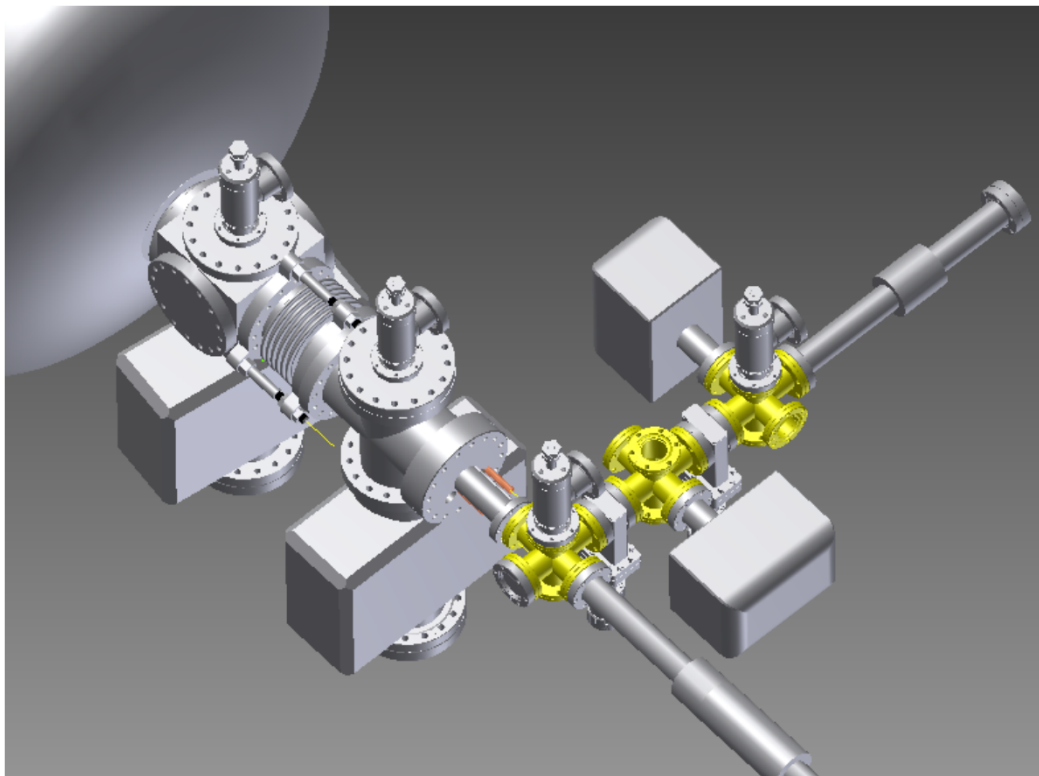


At 150C substrate temperature, the thickness on Mo and SS only 10% of that on copper (27 nm on Cu, 2.7 nm on Mo, 3 nm on SS). The coating thickness on SS and Mo is highly non-uniform. At room temperature and 100C, the thicknesses on all three substrates is equivalent (21 nm), and all three coatings are uniform to within 5%

112 MHz Gun

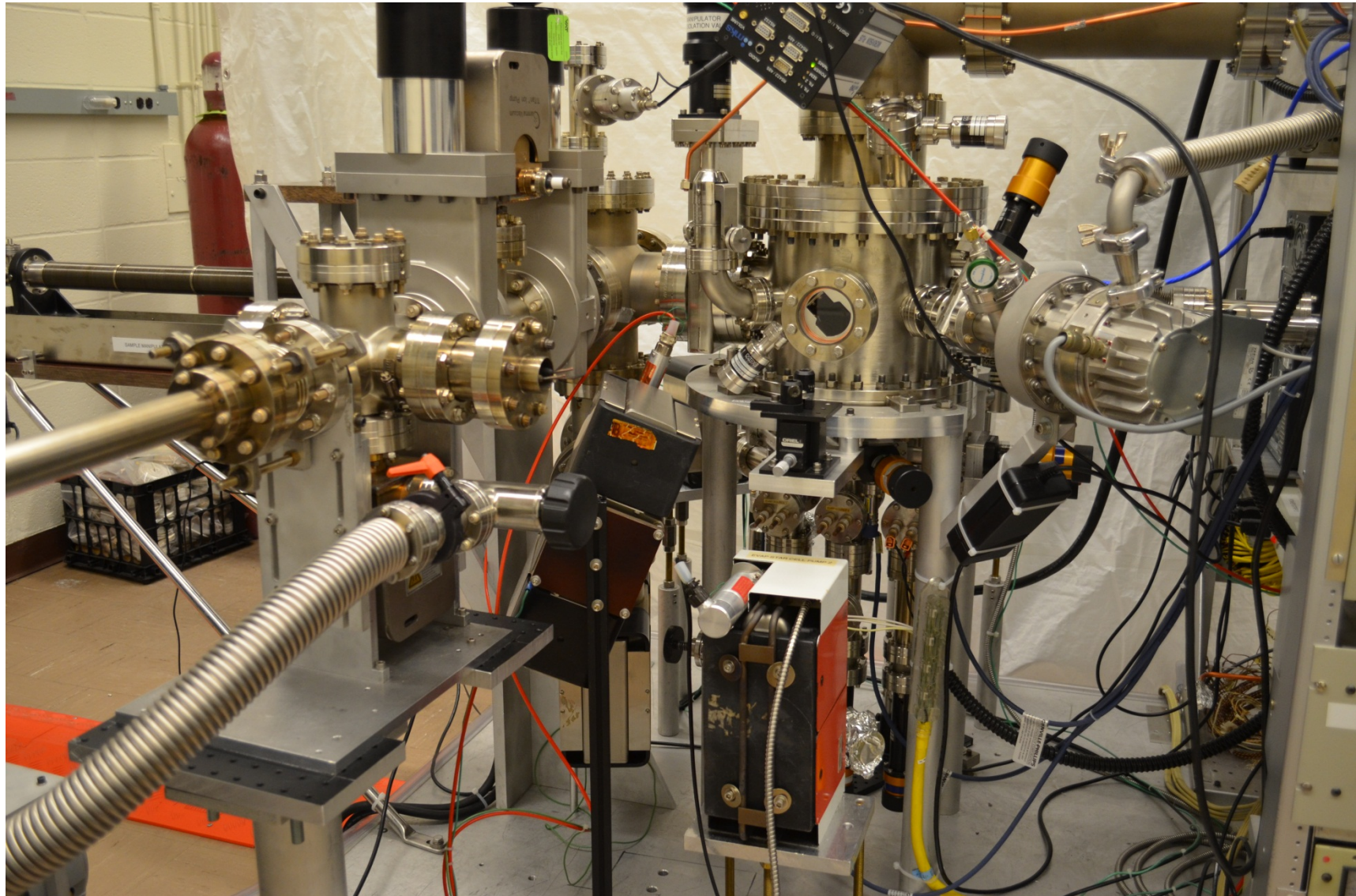


Load-Lock Design



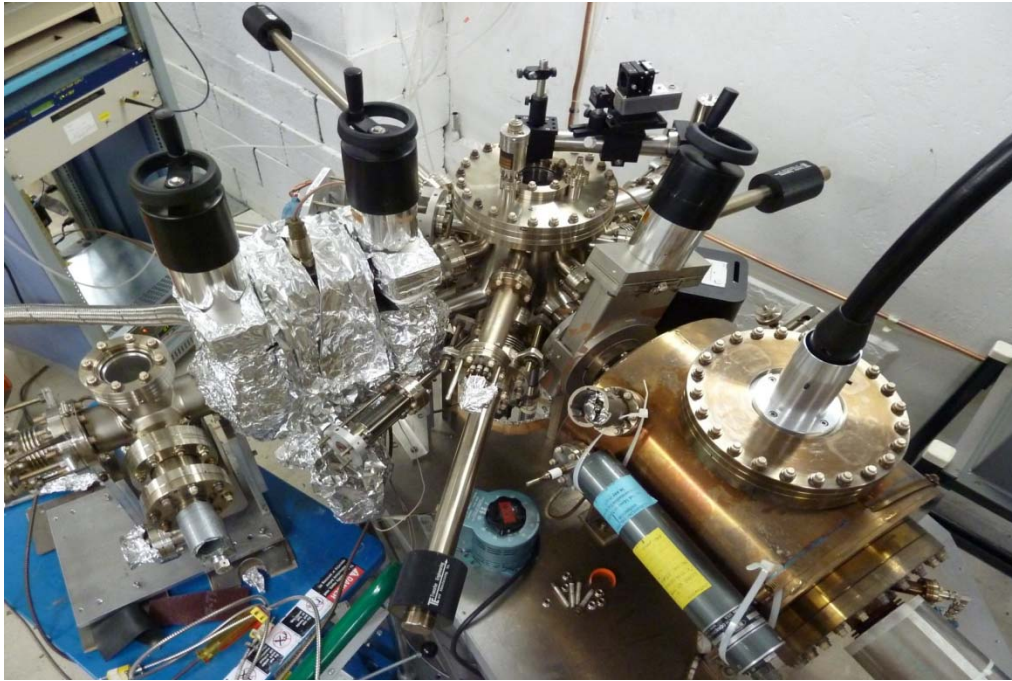
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Preparation Chamber



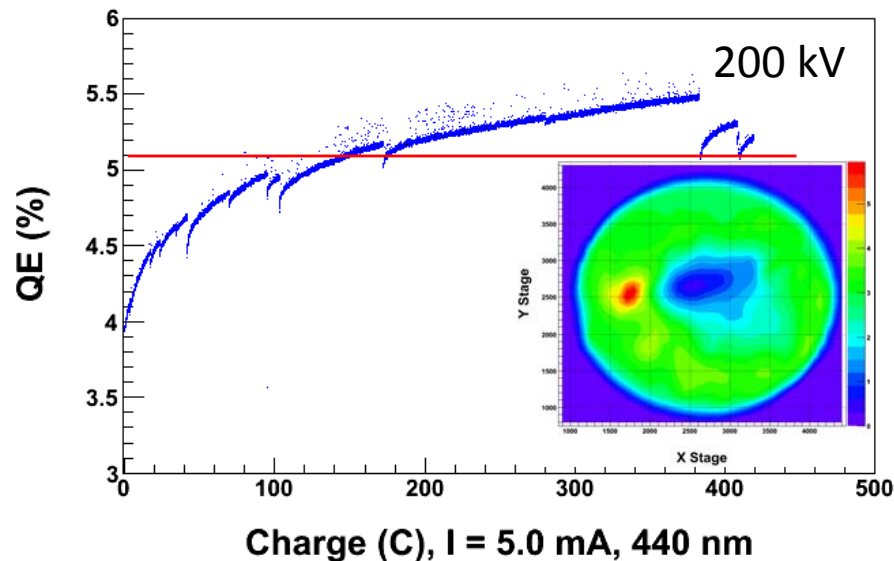
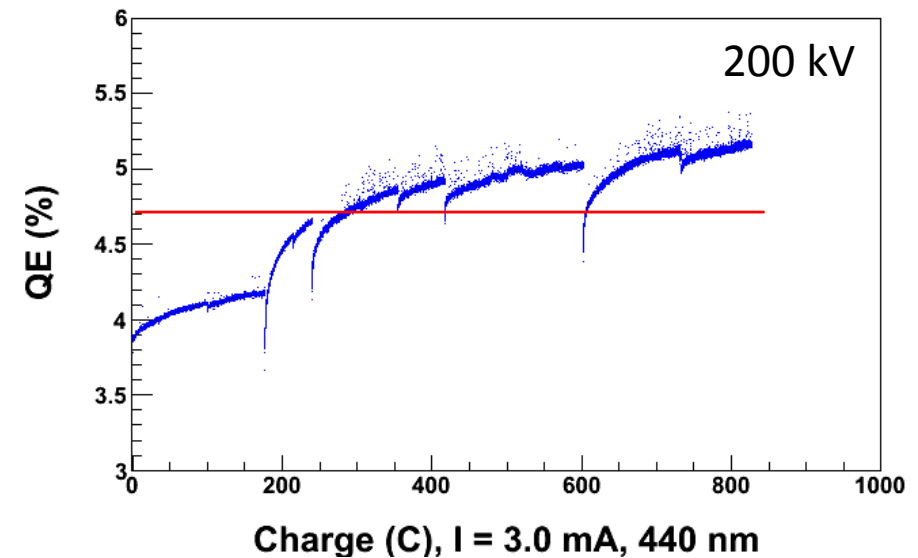
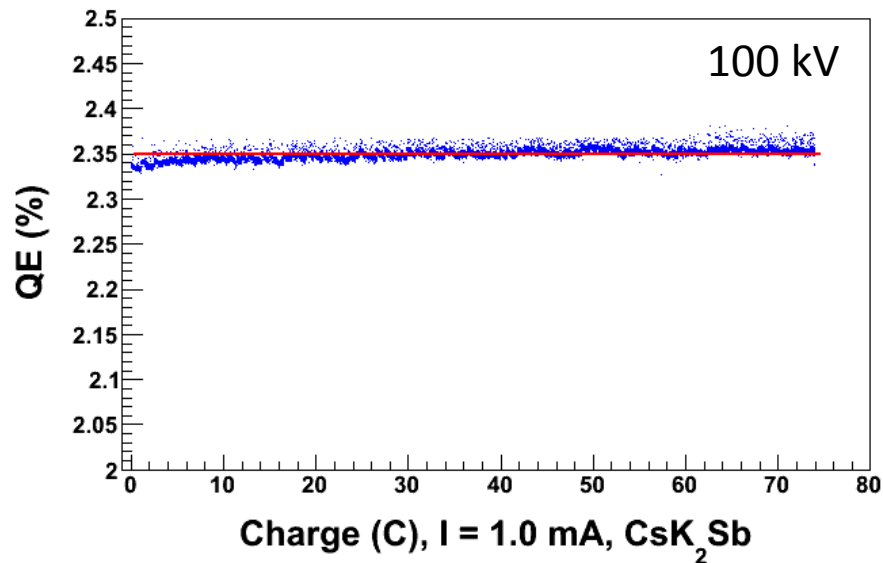
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DC Gun

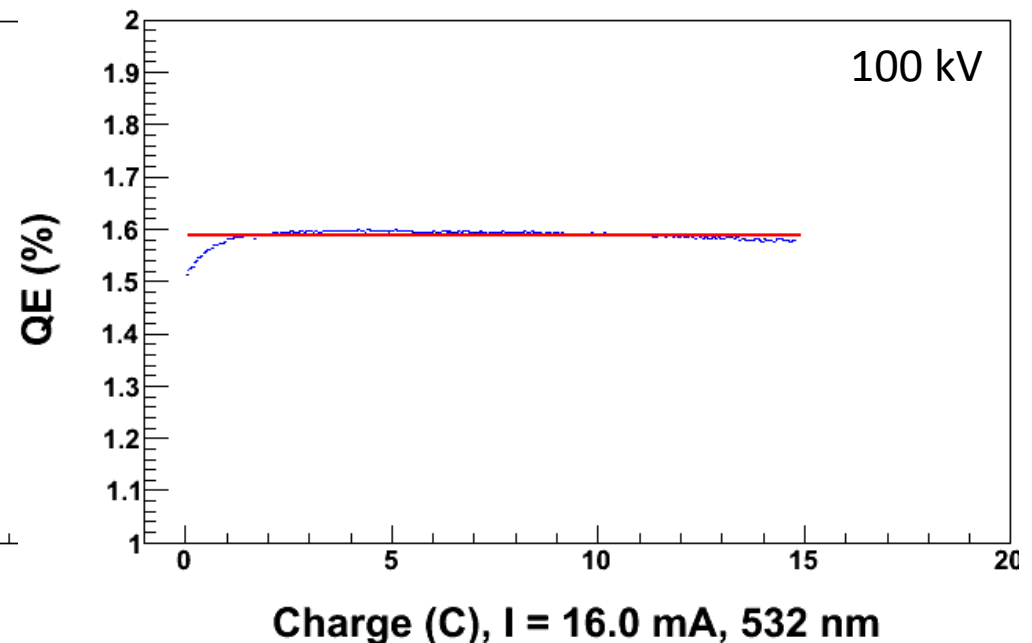
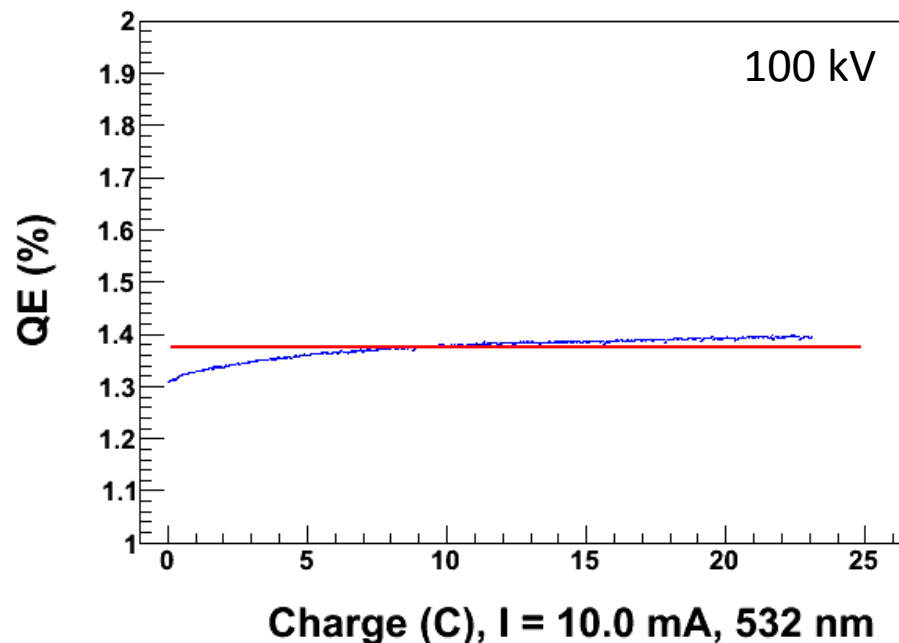


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Cathode transported successfully from BNL to JLab



440 nm, 850 micron FWHM
laser spot
Emission from EC
EC damaged during vacuum
incident
Other areas still capable of
emitting

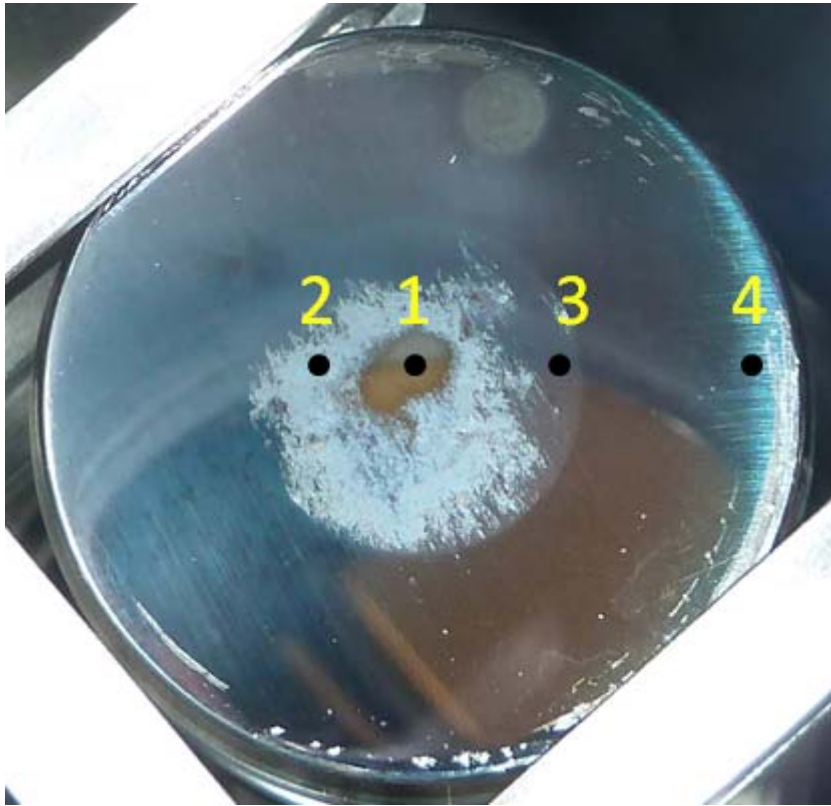


532 nm, 350 micron FWHM spot
Cathode degradation for 20 mA
Performance improved with larger spot size → Effects due to laser heating?

More information: Poster and talk by James McCarter

Cathode Characterization, Optimization

SEM measurements of JLab puck after use

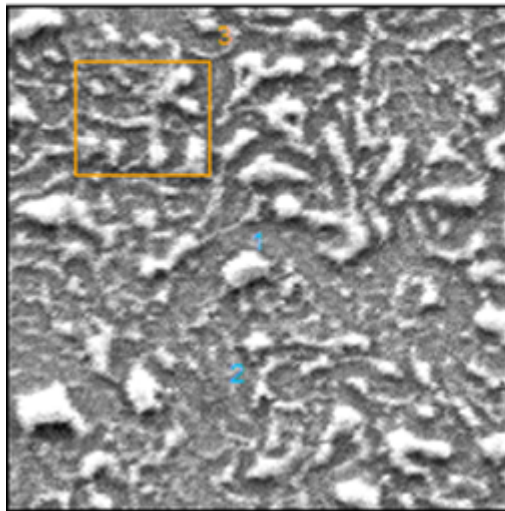


Cathode transported to
SEM in microtorr
vacuum/Argon
environment

Images were taken at
400X or 300X and 3000X.
Xray (elemental)
information was
obtained at 10, 15, 20
keV electron energies

CsK2Sb_frosted_region_10kvscan_ed

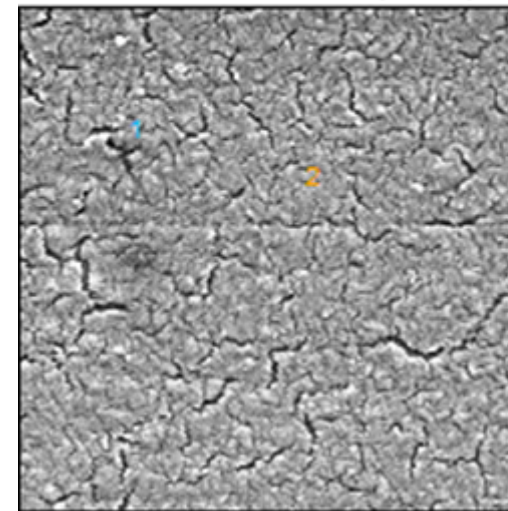
5 μ m



Spot 2

CsK2Sb_smooth_region_10kvscan_ed

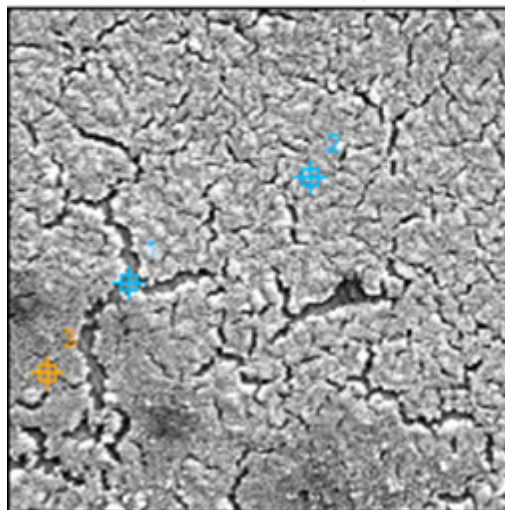
5 μ m



Spot 3

CsK2Sb_edge_region_10kvscan_ed

5 μ m



Spot 4

Cracks and Areas
between flakes are SS

Elemental Analysis

Spot 1

<i>Element</i>	<i>Weight %</i>	<i>Weight % Error</i>	<i>Norm. Wt.%</i>	<i>Atom %</i>	<i>Atom % Error</i>
<i>C</i>	2.51	+/- 0.31	2.51	10.65	+/- 1.29
<i>Si</i>	0.47	+/- 0.06	0.47	0.86	+/- 0.11
<i>Cr</i>	16.44	+/- 0.30	16.44	16.12	+/- 0.30
<i>Cr</i>	---	---	---	---	---
<i>Mn</i>	1.38	+/- 0.21	1.38	1.28	+/- 0.19
<i>Mn</i>	---	---	---	---	---
<i>Fe</i>	67.98	+/- 0.69	67.98	62.07	+/- 0.63
<i>Fe</i>	---	---	---	---	---
<i>Ni</i>	9.05	+/- 0.54	9.05	7.86	+/- 0.47
<i>Ni</i>	---	---	---	---	---
<i>Mo</i>	---	---	---	---	---
<i>Mo</i>	2.17	+/- 0.18	2.17	1.16	+/- 0.10
<i>Mo</i>	---	---	---	---	---
<i>Total</i>	100.00		100.00	100.00	

Spot 2

<i>Element</i>	<i>Weight %</i>	<i>Weight % Error</i>	<i>Atom %</i>	<i>Atom % Error</i>
<i>C</i>	4.11	+/- 0.34	15.46	+/- 1.27
<i>O</i>	10.91	+/- 0.30	30.80	+/- 0.86
<i>K</i>	2.50	+/- 0.18	2.89	+/- 0.21
<i>K</i>	---	---	---	---
<i>Cr</i>	10.46	+/- 1.14	9.09	+/- 0.99
<i>Cr</i>	---	---	---	---
<i>Fe</i>	35.93	+/- 2.78	29.06	+/- 2.25
<i>Fe</i>	---	---	---	---
<i>Sb</i>	14.21	+/- 0.69	5.27	+/- 0.25
<i>Sb</i>	---	---	---	---
<i>Cs</i>	21.88	+/- 1.06	7.44	+/- 0.36
<i>Cs</i>	---	---	---	---
<i>Total</i>	100.00		100.00	

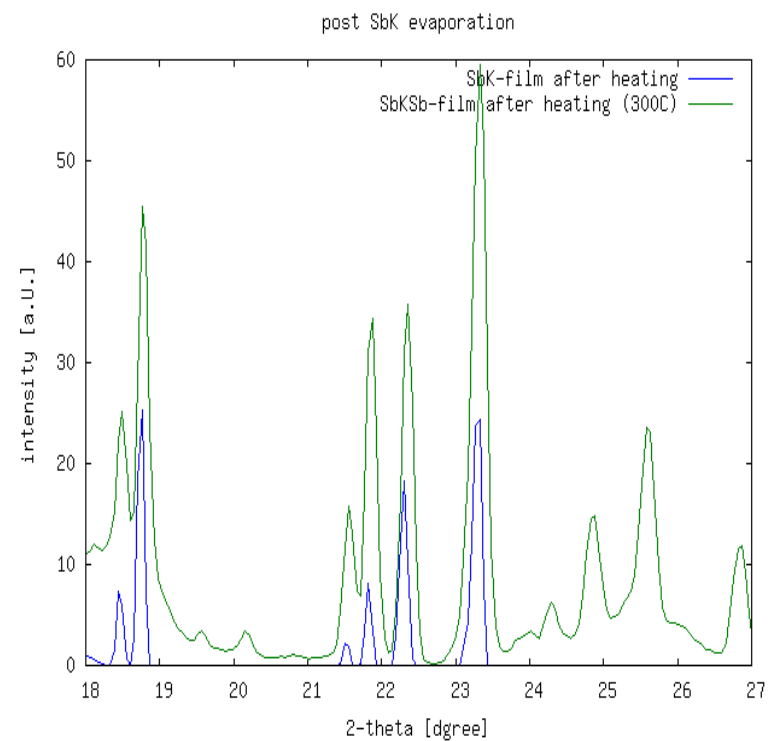
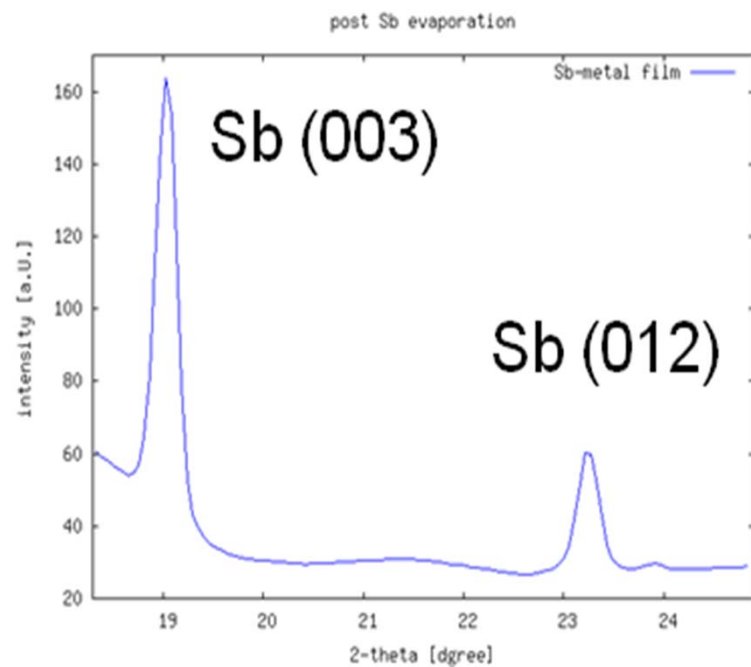
Spot 3

<i>Element</i>	<i>Weight %</i>	<i>Weight % Error</i>	<i>Atom %</i>	<i>Atom % Error</i>
<i>C</i>	4.74	+/- 0.38	17.55	+/- 1.42
<i>O</i>	13.20	+/- 0.31	36.71	+/- 0.86
<i>F</i>	1.08	+/- 0.56	2.52	+/- 1.31
<i>K</i>	4.88	+/- 0.44	5.56	+/- 0.51
<i>K</i>	---	---	---	---
<i>Cr</i>	6.32	+/- 0.99	5.41	+/- 0.84
<i>Cr</i>	---	---	---	---
<i>Fe</i>	17.59	+/- 1.40	14.02	+/- 1.11
<i>Fe</i>	---	---	---	---
<i>Sb</i>	25.22	+/- 2.09	9.22	+/- 0.76
<i>Sb</i>	---	---	---	---
<i>Cs</i>	26.97	+/- 2.41	9.03	+/- 0.81
<i>Cs</i>	---	---	---	---
<i>Total</i>	100.00		100.00	

Spot 4

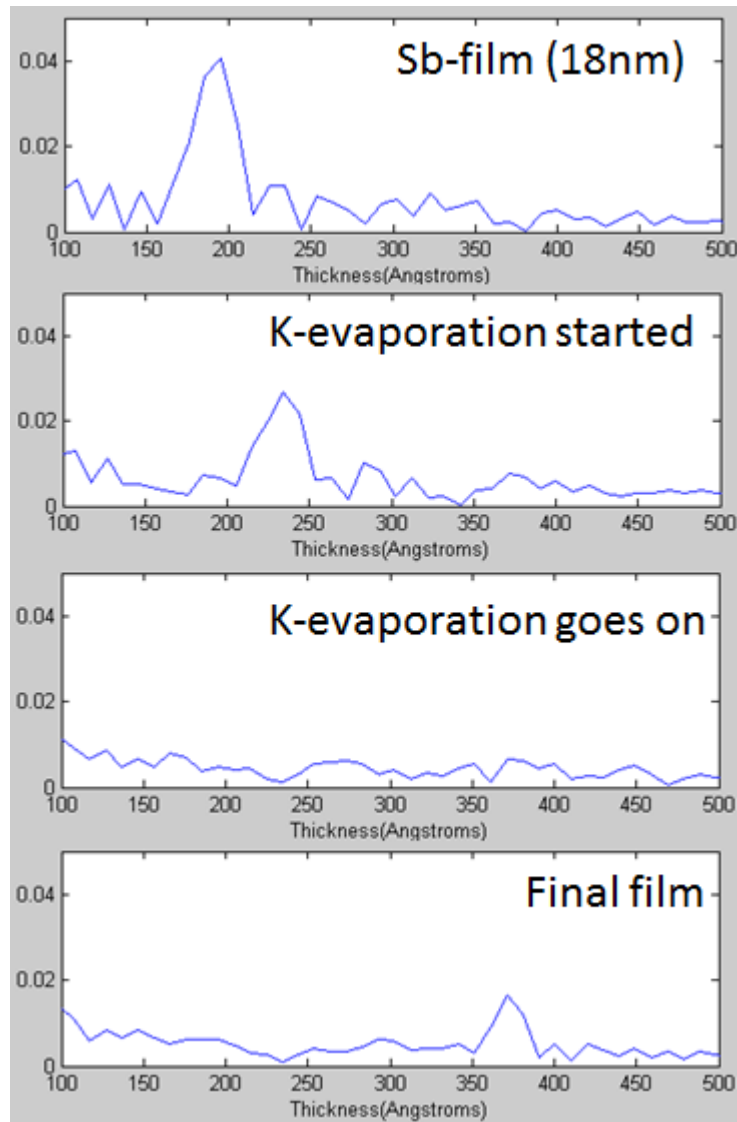
<i>Element</i>	<i>Weight %</i>	<i>Weight % Error</i>	<i>Atom %</i>	<i>Atom % Error</i>
<i>C</i>	5.77	+/- 0.36	19.86	+/- 1.25
<i>O</i>	14.18	+/- 0.33	36.63	+/- 0.85
<i>F</i>	0.68	+/- 0.59	1.48	+/- 1.29
<i>K</i>	5.25	+/- 0.43	5.55	+/- 0.46
<i>K</i>	---	---	---	---
<i>Cr</i>	6.54	+/- 1.13	5.20	+/- 0.90
<i>Cr</i>	---	---	---	---
<i>Fe</i>	22.53	+/- 2.61	16.68	+/- 1.93
<i>Fe</i>	---	---	---	---
<i>Sb</i>	20.72	+/- 0.78	7.03	+/- 0.26
<i>Sb</i>	---	---	---	---
<i>Cs</i>	24.32	+/- 1.10	7.56	+/- 0.34
<i>Cs</i>	---	---	---	---
<i>Total</i>	100.00		100.00	

XRD Measurements: Texturing of cathode surface



Texturing of Sb-K on heating

X-Ray Reflectometry (XRR)



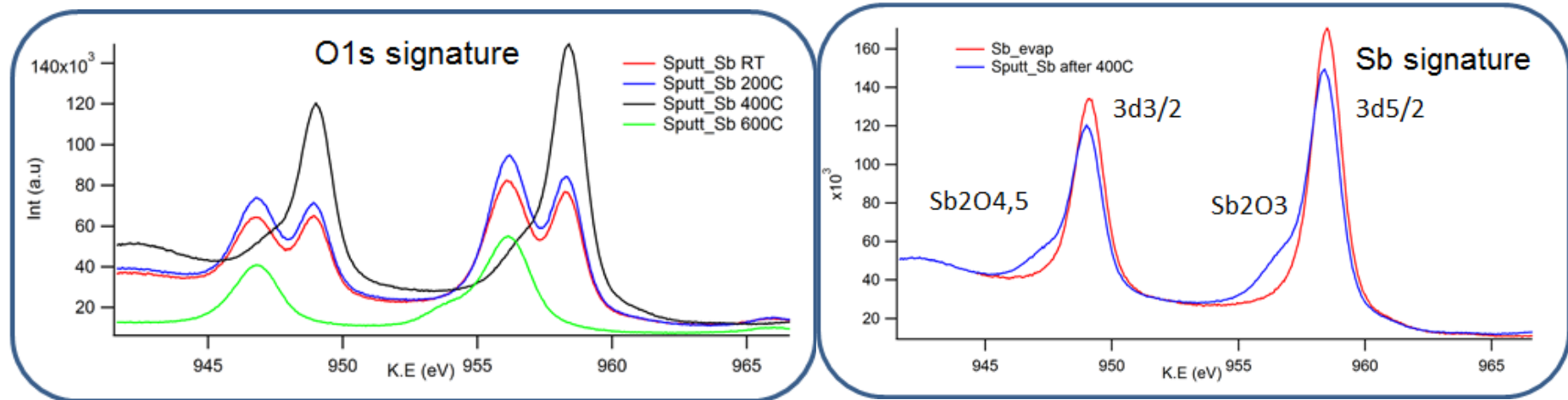
Strong Sb peak

Strength of Sb peak decreases

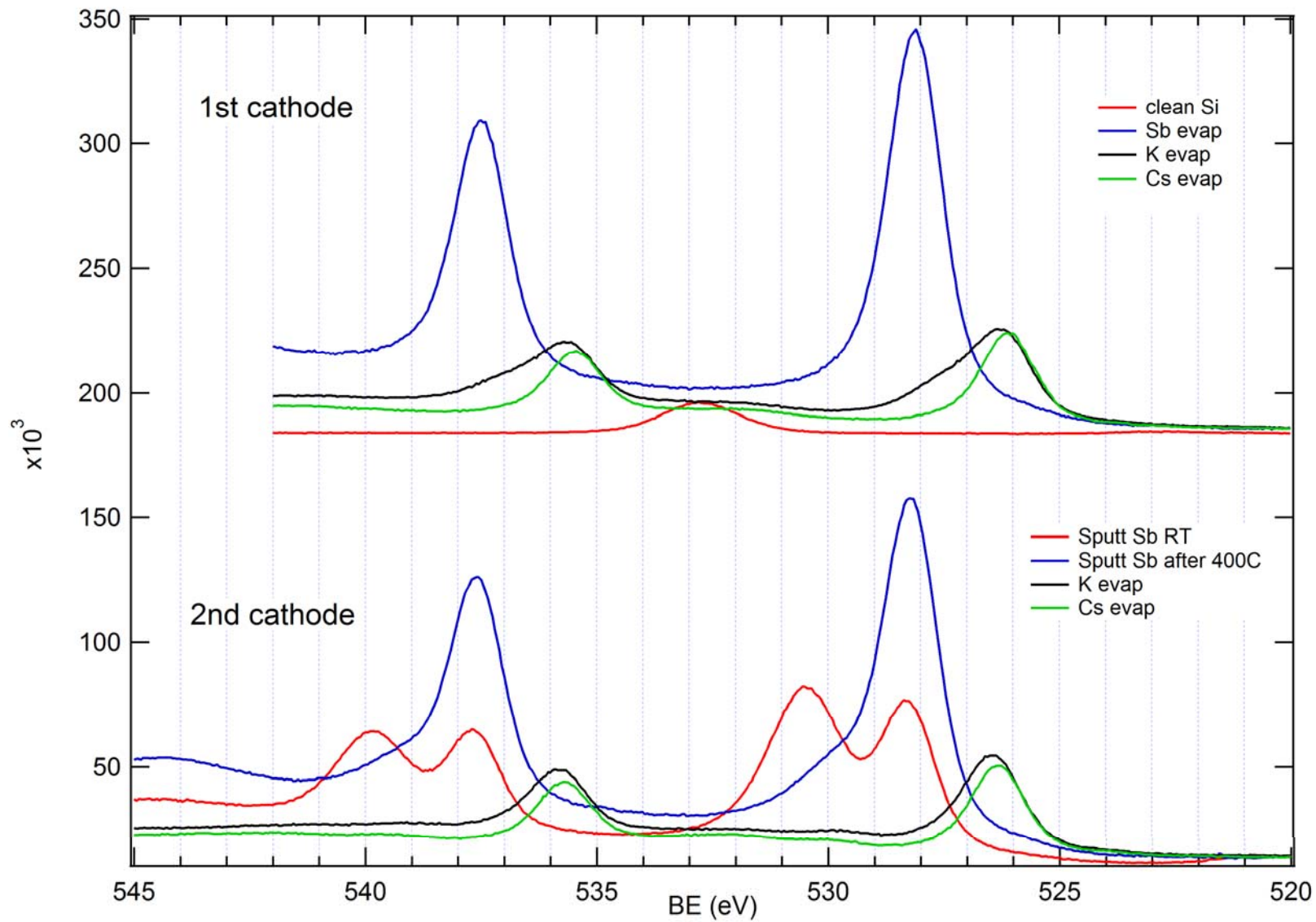
Sb peak vanishes-
Reaction to K

New Peak: Crystalline K_3Sb ?

Comparison of Sb layer production: Ex-situ Sb sputtered Si, heated to remove O



Comparison of Cathodes



Future Plans

- Cathode Test:
 - 704 MHz gun in a few months
 - 112 MHz within a year
 - DC gun ongoing, modify puck for X-Ray analysis
- Characterization and optimization:
 - Ongoing
 - New, UHV chamber under construction

Group Members

S. Belomestnykh

I. Ben-Zvi

X. Chang

J. Skaritka

J. Smedley

E. Wang

Q. Wu

E. Muller (SUSB)

M. Ruiz-Oses (SUSB)

X. Liang (SUSB)

T. Xin (SUSB)

K. Attenkofer (ANL)

S. Lee (ANL)

T. Schultheiss (AES)

K. Nelson (AES)

T. Vecchione (LBNL)